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Bib Data Sheet

CONFIRMATION NO. 2218

SERIAL NUMBER 09/903,600	FILING DATE 07/12/2001 RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. S004-4331
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APPLICANTS

Ryoichi Matsuoka, Chiba-shi, JAPAN;

**** CONTINUING DATA ********Name UC***** FOREIGN APPLICATIONS *******JAPAN 2000-214845 07/14/2000 *Yes UC***IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

** 08/23/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after allowance Verifier and Acknowledged <i>Wise</i> Examiner's Signature <i>CD</i> Initials				

ADDRESS

ADAMS & WILKS

31st Floor
50 Broadway
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TITLE

Wafer pattern observation method and device

FILING FEE RECEIVED 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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